



RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2851

00862.022438.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yoshinori MIWA

Application No.: 09/987,568

Filed: November 15, 2001

For: EXPOSURE APPARATUS AND EXPOSURE
METHOD

)
: Examiner: H. Nguyen
)
: Group Art Unit: 2851
)
: Confirmation No.: 7349
)
:
) June 2, 2004
:

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

AMENDMENT AFTER FINAL REJECTION

In response to the final Official Action dated April 8, 2004, please amend the

above-identified application as follows, pursuant to 37 C.F.R. § 1.116:

Please

Do not enter

6/19/04

HN